INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 16, 2026

IGI Report Number	LG837640868
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	11.29 X 7.04 X 4.56 MM

GRADING RESULTS

Carat Weight	3.63 CARATS
Color Grade	D
Clarity Grade	VVS 1

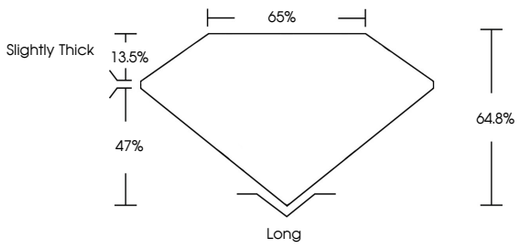
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG837640868

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG837640868
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

September 16, 2026
IGI Report Number LG837640868
Description LABORATORY GROWN DIAMOND
Shape and Cutting Style EMERALD CUT
Measurements 11.29 X 7.04 X 4.56 MM

GRADING RESULTS
Carat Weight 3.63 CARATS
Color Grade D
Clarity Grade VVS 1

65%
Slightly Thick
13.5%
47%
64.8%
Long

ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG837640868
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

September 16, 2026
IGI Report No LG837640868
EMERALD CUT
11.29 X 7.04 X 4.56 MM
Carat Weight 3.63 CARATS
Color Grade D
Clarity Grade VVS 1
Depth 64.8%
Table 65%
Girdle Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG837640868
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa